SURFACE IMPURITY REMOVAL FROM DIII-D GRAPHITE TILES BY BORON CARBIDE GRIT BLASTING

by

This is a preprint of a paper to be presented at the 15th IEEE/NPSS Symposium on Fusion Engineering, October 11–15, 1993, in Hyannis, Massachusetts, and to be printed in the Proceedings.

Work supported by
U.S. Department of Energy
Contract DE-AC03-89ER51114

GENERAL ATOMICS PROJECT 3466
NOVEMBER 1993
SURFACE IMPURITY REMOVAL FROM DIII-D GRAPHITE TILES BY BORON CARBIDE GRIT BLASTING

General Atomics
P.O. Box 85608, San Diego, California 92186-9784

ABSTRACT

During the latter half of 1992, the DIII-D tokamak at General Atomics (GA) underwent several modifications of its interior. One of the major tasks involved the removal of accumulated metallic impurities from the surface of the graphite tiles used to line the plasma facing surfaces inside of the tokamak. Approximately 1500 graphite tiles and 100 boron nitride tiles from the tokamak were cleaned to remove the metallic impurities. The cleaning process consisted of several steps: the removed graphite tiles were permanently marked, surface blasted using boron carbide (B₄C) grit media (approximately 37 μm diam.), ultrasonically cleaned in ethanol to remove loose dust, and outgassed at 1000°C. Tests were done using graphite samples and different grit blaster settings to determine the optimum propellant and abrasive media pressures to remove a graphite layer approximately 40–50 μm deep and yet produce a reasonably smooth finish. EDX and beta-backscattering measurements revealed that the blasting technique reduced the surface Ni, Cr, and Fe impurity levels to those of virgin graphite. Auger analysis of blasted tile samples does not show surface impurities within the first few atomic layers. An estimate of the depth of surface roughness due to the B₄C abrasive action is ±20 μm. In addition to the surface impurity removal, tritium monitoring was performed throughout the cleaning process. A bubbling system was set up to monitor the tritium level in the exhaust gas from the grit blaster unit. Surface wipes were also performed on over 10% of the tiles. Typical surface tritium concentrations of the tiles were reduced from about 500 dpm/100 cm² to less than 80 dpm/100 cm² following the cleaning. This tile conditioning, and the installation of additional graphite tiles to cover a high fraction of the metallic plasma facing surfaces, has substantially reduced metallic impurities in the plasma discharges which has allowed rapid recovery from a seven-month machine opening and regimes of enhanced plasma energy confinement to be more readily obtained. Safety issues concerning blaster operator exposure to carcinogenic metals and radioactive tritium will also be addressed.

INTRODUCTION

During the latter half of 1992, the DIII-D tokamak at GA underwent several modifications of its interior [1]. One of the major tasks involved the removal of accumulated metallic impurities from the surface of the graphite armor tiles. Scanning electron microscope (SEM) photographs of tiles removed from DIII-D revealed that most of the Ni, Cr, and Fe impurities were within the top 20 μm of the tile surface. Impurity influx into the discharges often results in degraded plasma performance. The dominant metallic impurity in the plasma discharges was nickel, which is the major component of the Inconel vessel wall. Iron, chromium, copper, and bromine were also present as impurities in the discharges. Fig. 1 is an energy dispersive X-ray, or EDX, scan of a tile removed from DIII-D prior to grit blasting showing peaks for the main metallic impurities. The relatively high proportion of Ni and Cr species are clearly evident and detectable amounts (approximately 37 l.

*Manuscript received October 14, 1993. This work was sponsored by the U.S. Department of Energy under Contract No. DE-AC03-89ER51114.
plasma from about 40% to nearly 100%. Concurrent with the addition of new tiles to DIII-D, all of the old tiles were removed and cleaned to remove surface impurities. The goal of the cleaning process was to remove Ni, Cr, Fe, Cu, and Br from the tile surfaces. Approximately 1500 graphite tiles and 100 boron nitride tiles were removed from the tokamak and processed.

CLEANING PROCEDURE

The cleaning procedure for the tiles removed from DIII-D consisted of several steps: First, surface wipes were taken on approximately 10% of the tiles to measure removable surface tritium, alpha, and beta contamination levels. Second, each of the removed graphite tiles was permanently marked with its toroidal and poloidal locations and tile type using a hand-held vibration etcher [2]. Next, the tiles were grit blasted using boron carbide media and ultrasonically rinsed in ethyl alcohol to remove loose graphite and media dust. Boron carbide media blasting has been successfully performed in TEXTOR to clean graphite limiter blades [3]. A different tile surface cleaning technique using silicon carbide sandpaper and scouring pads has been used on TFTR [4]. For the tiles removed from DIII-D, the grit blasting method was chosen because it offered an efficient way to clean a large number of tiles. The final stage of tile cleaning consisted of outgassing the tiles at 1000°C for 4 h to remove residual trapped alcohol and other gases within the tile bulk. Throughout the entire process, each tile was carefully tracked using log sheets which indicated the status of each tile. Any broken or chipped tiles were repaired or replaced when necessary.

The dry abrasive blaster used for grit blasting was from Media Blast & Abrasives. The unit was a negative pressure, dual chamber model [5]. The unit was chosen for its ability to trap residual particles which may have a low level of radioactive or carcinogenic contamination. Negative pressure in the blaster unit was developed from a built-in high speed fan having a throughput velocity of 20 m³/min on the exhaust port of the unit. A cyclone separator exhausted all light graphite and boron carbide dust through the filters while allowing the heavier abrasive boron carbide particulates to be recycled through the unit. The filtering system included an inlet filter set, an intermediate dual canister filter set, and a high efficiency particulate (HEPA) filter on the exhaust port. The HEPA filter trapped all particles greater than 0.12 μm.

Boron carbide was used as the blasting media because it is an effective abrasive for graphite and the presence of residual boron carbide on the tiles is acceptable for plasma operations since boron is a low Z element and is generally present on the graphite surfaces from frequent wall conditioning boronizations of DIII-D. The spray pattern from the boron carbide nozzle was circular with an angular width of about 22 deg. The media grit size was approximately 37 μm, but varied from 20 to 65 μm [6]. Grit smaller than about 20 μm was not utilized effectively by the blaster unit and particles larger than about 60 μm may remove more of the graphite tile surface than was desired, although no measurements to assess this effect were done. A manually operated expanded metal turntable inside the blasting chamber allowed for rotation of the target tiles during blasting operations. A small graphite shelf was made on which to place the tiles during grit blasting to keep the media gun from discharging directly onto the expanded metal of the turntable or the interior steel walls of the chamber thus avoiding undue metallic contamination. Before grit blasting any armor tiles, graphite removal rates were determined by grit blasting graphite test coupons (4 x 4 x 1 cm) using various blaster settings. Room temperature gaseous nitrogen propellant pressure was varied from 10 to 30 psi. The gas was taken from LN₂ boil-off to ensure minimal contamination. The media delivery pressure, which affected the particle density, was changed between 5 and 10 psi. The distance between the media gun nozzle and tile surface was 15 to 20 cm and the nozzle was kept perpendicular to the surface being cleaned. The depth of material removed per pass varied from 2.2 to 22 μm and was linear with either the propellant or media pressure.

Auger measurements indicated the impurities were present to a depth of approximately 30 μm beneath the tile surface. Thus, the working range for propellant and media pressure values and the number of passes was chosen so that the total removed depth of material was between 25 and 50 μm. When grit blasting the plasma facing surfaces of the tiles, we chose to obtain this depth in three passes of the media nozzle which would retain a relatively good surface flatness without excessive material being removed or producing gouging during any single pass. The settings used included a propellant pressure of 25 psi and a media pressure of 15 psi. The first and second passes were orthogonal to each other and the third pass was at a 45 deg angle with respect to the first two passes. The remainder of the tile surface, including sides, feet, and bottom, received three passes as well. Three tiles at a time were placed into the blasting chamber. The operator timed the overall blasting process and turned the tiles when required. The plasma facing surface on each tile was blasted for approximately 1 to 1.5 minutes, to remove primarily metallic impurities. Bromine had previously been found on nonplasma facing surfaces of some tiles and these surfaces of each tile were blasted for a total of 2 minutes. The abrasive action of the grit was reduced after repeated use and replacement of the 18 kg media charge was performed after approximately 300 tiles were cleaned.

Operator safety while handling and processing the tiles was an important part of the overall cleaning process. While operating, the media blaster unit was fully sealed and under negative pressure. Graphite particulates, some of which contained carcinogenic nickel atoms, and boron carbide grit were contained within the blaster unit during operation. However, had there been a catastrophic failure of the sealing portions or filtering systems of the blaster, it was estimated that approximately 4 g of graphite and boron carbide could be
ejected from the unit during a 30 sec shutdown period. Calculations of the resulting particulate and nickel volume-averaged concentrations would be 6 mg/m³ and 0.05 mg/m³, respectively, below levels requiring a face mask. Thus, a face mask was not required during normal operations of the blaster, but was used while transferring tiles to and from the blaster unit. Calculations also showed that without proper ventilation a high level of the nitrogen propellant from the blaster might accumulate, thereby reducing the available oxygen level. Hence, external ventilation of the exhaust was established using 30 cm ducting compatible with the blaster unit’s throughput volume.

Analyses for the presence of residual radioactive species were performed to determine safe handling procedures and document the quantity of radioactive species present. A tritium bubbler system was used to monitor grit blaster and vacuum-oven exhausts for the presence of released tritium [7]. Surface wipes which measure removable alpha, beta, and tritium species were done on many tiles. No amounts of removeable alpha or beta species above background were found. No neutron activation above background was observed in the tiles. However, on many tiles, tritium was found to be located both on the surface of the tile and in the bulk. Surface wipes for tritium revealed concentrations ranging from a background level of 40 dpm/100 cm² on a ceiling tile to a maximum of 3400 dpm/100 cm² found on one of the limiter tiles. The maximum surface tritium level for unrestricted release is 1000 dpm/100 cm². Measurements of tritium released during high temperature bakes of some blasted and unblasted tile samples revealed that about 96% of the tritium was removed by the grit blasting. Thus, the tiles were able to safely go off-site for baking without restrictions. Contaminated graphite particles were trapped by the filtering system. Latex gloves were used when handling the tiles and contaminated grit was transferred to Health Physics for inventory and disposal.

**TILE SURFACE IMPURITIES AND THEIR REMOVAL**

The tiles are made from ATJ graphite, which has a total ash, or impurity, content between 0.1% and 0.2%. Over 80% of these impurities include S, Ca, Fe, and V [8]. Other impurities present in the bulk material include small amounts of Al, Ti, Ni, Si, and Pb. The deposition of metallic impurities on the surface of DIII-D tiles and subsequent analysis using external particle induced X-ray (X-PIXE) techniques have been previously reported [9]. However, during the present tile reconditioning task, the methods used for observing metallic impurities on the tile surface were Auger analysis and a β-back-scatter microphotographic technique. A portable β-back-scatter probe was also used for estimating gross impurity removal effectiveness, but was not calibrated for any particular metallic species. Fig. 2 is a β-back-scatter microphotograph (350×) showing the surface edge of a tile prior to blasting. The bright regions along the edge of the surface are metallic impurities in the unblasted graphite surface. The metallic impurities are within the top 5 to 10 μm of the plasma striking surface of the tiles, but due to the open porosity of the graphite, some impurities are present along the inner perimeter of the surface pores. The pores are typically 15 to 20 μm deep and, therefore, the effective depth of impurity concentration may be up to 30 μm.

Fig. 3 is a microphotograph (100×) of the profile of a tile surface which has been grit blasted. No metals are evident on the surface of the tile or within any of the open surface pores. Comparison of this figure with the previous one shows the blasted surface is rougher than that of the unblasted sample. Measurements of the surface irregularity shows a maximum profile height of 16 μm for the unblasted sample and 36 μm for that of the blasted sample. EDX scans made of blasted tile surfaces do not show metallic contamination above that of background.

![Fig. 2. Metallic impurities are evident along the surface of a sectioned tile removed from DIII-D prior to grit blasting (350×).](image1)

![Fig. 3. The surface of a grit blasted tile shows no metallic impurities (100×).](image2)
SUMMARY

Over 1600 graphite and boron nitride tiles were removed from DIII-D for surface cleaning using boron carbide grit blasting and high temperature baking procedures. The major surface impurities, Ni, Fe, Cr, Cu, and Br were effectively removed without damage to the tiles during the grit blasting. Ultrasonic cleaning of the tiles in alcohol followed by high temperature baking insured that no residual loose boron carbide dust or alcohol were left in the tiles. In addition, tritium monitoring of sample lots of the tiles during grit blasting and bake-out indicate that more than 96% of tritium is removed during the entire procedure. The process of cleaning the existing tiles along with covering the additional plasma facing metallic surfaces with new tiles successfully reduced plasma impurities and led to enhanced plasma performance.

ACKNOWLEDGMENTS

The authors wish to extend their appreciation to the DIII-D technical staff for their expert assistance during all phases of the tile reconditioning and installation process. We also wish to extend thanks to Don Wall, who prepared the Auger and EDX data.

REFERENCES

[5] Media Blast & Abrasives, Inc., 5126 Chakemco St. P.O. Box 1264, South Gate, California.
[8] UCAR, Cleveland, Ohio.
END

19/10/94

FILE

DATE